

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date submitted to PTO: November 21, 2003			ATTY DOCKET NO. <div style="text-align: center; font-weight: bold;">03500.017563</div>		APPLICATION NO. <div style="text-align: center; font-weight: bold;">10/665,571</div>	
			APPLICANT <div style="text-align: center; font-weight: bold;">SHINJI ERITATE, ET AL.</div>			
			FILING DATE <div style="text-align: center; font-weight: bold;">Sept mb r 22, 2003</div>		GROUP <div style="text-align: center; font-weight: bold;">Not Y t Assigned</div>	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6,382,775 B1	05/07/02	Kubota et al.	347	62		
	6,331,259 B1	12/18/01	Ozaki et al.	216	27		
	6,277,294 B1	08/21/01	Ozaki et al.	216	27		
	6,391,527 B2	05/21/02	Yagi et al.	430	313		
	6,436,301 B1	08/20/02	Hiroki et al.	216	27		
	6,474,780 B1	11/05/02	Kubota et al.	347	45		

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
9-92897	04/04/97	Japan			Abstract		
10-139594	05/26/98	Japan			Abstract		
10-290035	10/27/98	Japan			Abstract		

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
<div style="font-size: 2em; font-weight: bold;">GM</div>	C. V. R. Vasant Kumar, et al., "Lead Zirconate Titanate Films by Rapid Thermal Processing," Appl. Phys. Lett., vol. 58, no. 11, March 18, 1991, pp. 1161-1163.

EXAMINER	DATE CONSIDERED <div style="font-weight: bold;">5/3/2005</div>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.